



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2818
Examiner: David Nhu

Re PATENT APPLICATION of:

Applicant(s) : Takashi NAKAMURA)

Serial No. : 09/856,818)

Filed : May 25, 2001)

For: METHOD OF FORMING SOLID OF A FERROELECTRIC
OR HIGH DIELECTRIC MATERIAL AND METHOD OF
MANUFACTURING SEMICONDUCTOR DEVICE
EMPLOYING THE SAME)

Attorney Ref. : AI 265NP)

) **INFORMATION DISCLOSURE
STATEMENT**

Notice of Allowance Date: November 7, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(d) after Notice of Allowance, but before payment of the Issue Fee. As required by 37 C.F.R. §1.97(e)(1), it is certified that each item submitted with this Information Disclosure Statement was first cited in the attached Office Action from the Japanese Patent Office in a counterpart foreign application on October 7, 2003, that is, less than three months prior to filing this Information Disclosure Statement.

Enclosed are copies of the Japanese Patent publication and the PCT application cited therein. The relevance of the Japanese publication can be gleaned from the attached English language Abstract. The documents are listed on the attached Form PTO-1449. Also enclosed is the applicable fee of \$180.00 required by 37 C.F.R. §1.17(p).

Consideration of the submitted documents is respectfully requested.

Respectfully submitted,

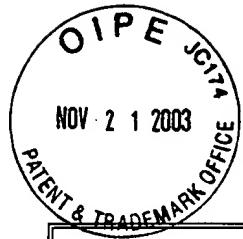

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SMR:tlc


FORM PTO-1449
INFORMATION DISCLOSURE STATEMENT

Atty. Docket	Application No.
AI 265NP	09/856,818
Applicant	
Takashi NAKAMURA et al	

 Filing Date
 May 25, 2001

 Group
 2818

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Trans-lation
	AI	WO 96/29726	9/26/96	PCT			English
	AJ	05-85706	6/4/93	JAPAN			Entire
	AK						
	AL						
	AM						
	AN						

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

AO	
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Examiner _____ Date Considered _____

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.